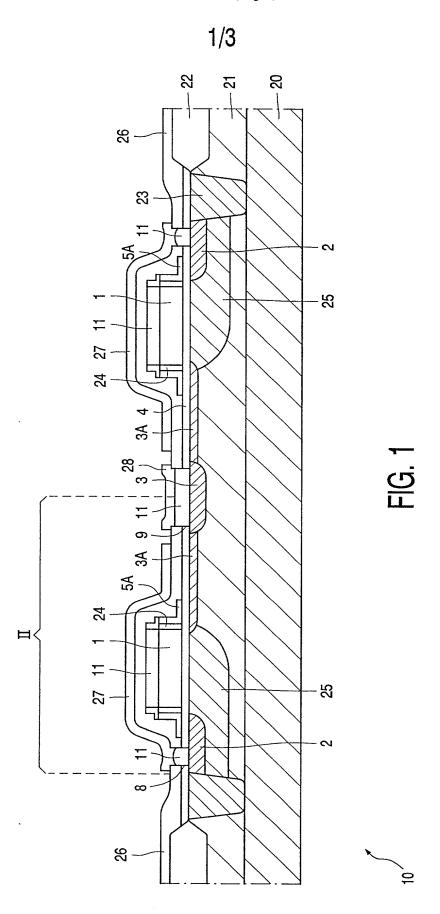
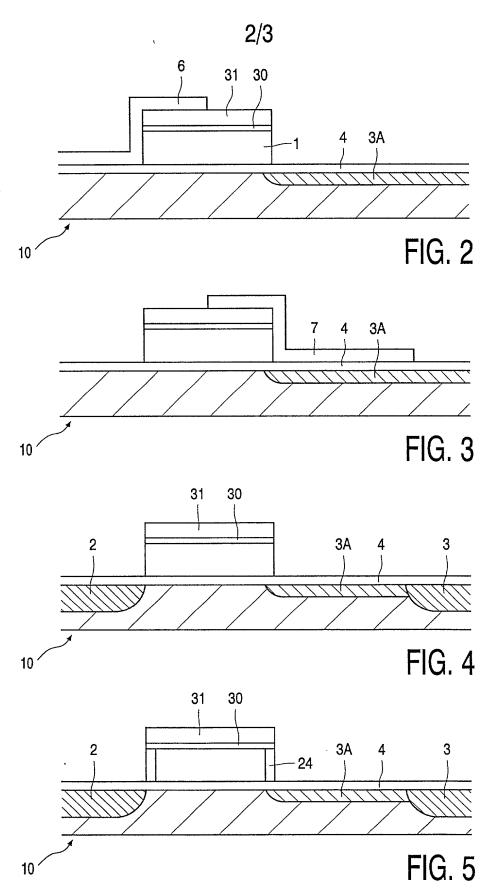
RENERUS A. VAN DEN HEUVEL NL 000674 METHOD FOR THE MANUFACTURE OF A SEMICONDUCTOR DEVICE WITH A FIELD-EFFECT TRANSISTOR STEVEN R. BIREN, Reg. 26,531



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